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\*\* CONTINUING DATA \*\*\*\*\*  
 This application is a DIV of 09/605,660 06/28/2000 PAT 6,746,972 *KAY, TM*

\*\* FOREIGN APPLICATIONS \*\*\*\*\*  
 REPUBLIC OF KOREA 99-25341 06/29/1999 *KAY, TM*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED  
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Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Examiner's Signature <i>TM</i> Initials	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 7	TOTAL CLAIMS 5	INDEPENDENT CLAIMS 1
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TITLE  
 Apparatus for and method of heat-treating a wafer